"The Laser Microengineering Experimental Station" at the

Jefferson Laboratory Free Electron Laser Facility

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LPC 2004



Project Goals

- Establish a working facility that will enable user-friendly application
 of the unique FEL properties for investigations in laser
 microengineering science and laser material processing technology
 development.
- Effort delineated into two segments.
 - Build
 - an engineering model and process development station at The Aerospace Corporation - called Aerospace-Engineering Model (A-EM)
 - a working model at the Jefferson FEL called JLAB-working Model (JLAB-WM)

Operate

- transition newly developed laser processes and techniques,
- conducting fundamental investigations in laser material interaction phenomenon,
- assisting/guiding new users.



Examples of laser microengineering possible

- Multi-color direct-write microfabrication
- Volumetric exposure, multi-photon exposure processing
- Percussion machining, ablative machining
- Polishing
- Chemical vapor deposition (with special cell)
- Crystallization
- Micro-fusing
- Surface texturing
- Investigations: Laser material interaction phenomena
- Mass & optical spectroscopy of desorption and ablation
- Mass removal rate measurement
- Pump-probe physics
- Multiple pulse rep-pulse physics
- Small Scale Pulsed Laser Deposition (PLD)



System Attributes

- A laser beam delivery system for processing in the UV and IR.
- Automated sequencing of tool changes (e.g. color, objective).
- User selects from three focusing objectives.
- A coordinated three-axis motion system, XY motion range of 100mm.
- An optical table with integrated vibration isolation capability.
- An automated means for laser power and repetition rate control.
- A vision system for process control.
- A means for the User to measure the laser spot size & intensity distribution.
- CAD software for solid modeling of patterns.
- CAM software for generating 3 axes tool-path.
- Software for visual verification of the tool-path geometry.
- Software for converting the tool-path geometry into motion language.
- A generic scheme for mounting user supplied sample holders.
- An enclosure that can be interlocked with JLAB FEL safety systems.
- Additional laser beam delivery lines & stations for other experiments.

Designing for Vibration Control

Motion System is the Primary "Vibration" Noise Source

Approach

Apply a Multi-tiered Solution to Vibration Control Apply FEM Methods to Articulate Geometries that Enhance Stiffness



Recommended by Aerotech to use solid granite table and solid granite "bridge/superstructure" for z-drive mounting

- All tapped-hole locations prespecified
- Very heavy
- Claimed granite was ideal for stiffness
- Granite has same specific stiffness as steel
- Geometry has strong affect on stiffness

Weight 12,000 lbs

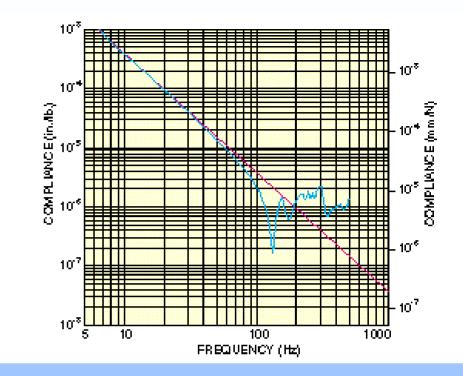


Newport RS 4000 Tables

Maximum Amplification at a Resonance (Q)

Steel Honeycomb Core: $Q = 1.1 \times 10^{-5} / 3 \times 10^{-6} \sim 4$

Granite Block: $Q = 2.3 \times 10^{-4} / 5 \times 10^{-7} = 460$



Worst Case Relative Motion Value (RM) RM = $2g(1/32\pi^3)^{1/2} (Q/f^3)^{1/2} (PSD)^{1/2} T$

For Q = 1, f=160 Hz, $PSD^* = 10^{-5} g^2/Hz$, T = 0.01

RM = 10nm

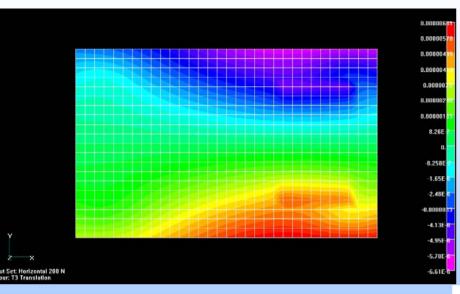
* PSD value is 10⁴ times the PSD vibration found in a light manufacturing factory

Static Deflection (SD) SD = (PL³/24EbTH²) +(PL/4GHb)

For P = 1000 lbs, L=52", b=60" and H =12", T=0.1875", E =29x10⁶ psi, G = 2.25x10⁵ psi

 $SD \sim 3.2 \times 10^{-4}$ " (8 µm)





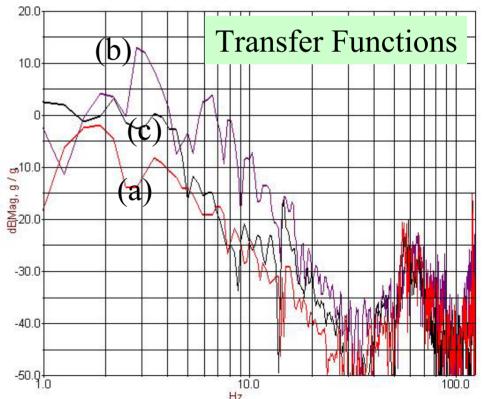
FEM of table top: Static deflections

Vertical deflection due to horizontal load				
Applied Force Deflection				
100 N	0.084 microns			
200 N	0.17 microns			
1100 N	0.92 microns			

Isolation System Design Multi-tiered Approach

- 1. Pneumatic isolation (a)
- 2. + Elastomeric isolation (b)
- 3. + Magnetic-active isolation (c)

Working isolation system with enhanced rigidity



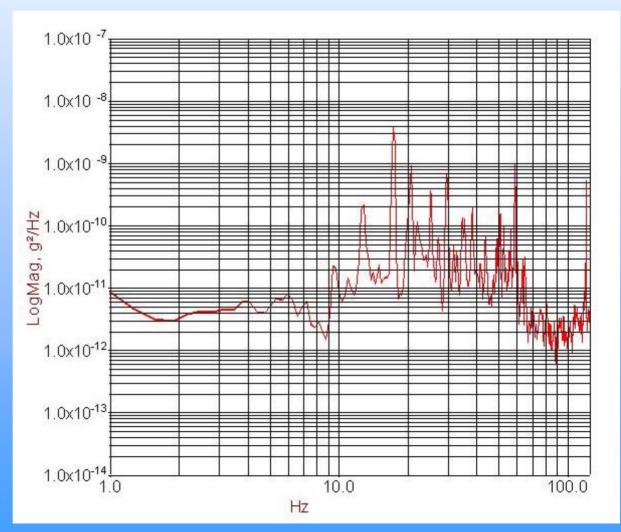
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Measure Aerospace Lab Floor Noise for baseline

Power Spectral Density Values

10⁻⁹ considered a Quite Laboratory

10⁻⁸ Light Manufacturing





The SuperStructure



Legs 8" square

1209.08 lbm

Modes: 1 49.77 Hz

2 110.55 Hz

3 129.42 Hz

Legs 4" OD, 1/8"wall

324.65 lbm

Modes: 1 64.95 Hz

2 64.95 Hz

3 96.65 Hz

- 1/4" wall: 645 lb, 73 Hz

Legs 4" square, 1/8"wall

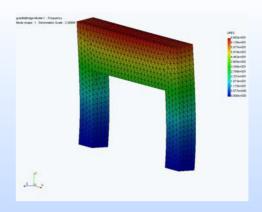
317.42 lbm

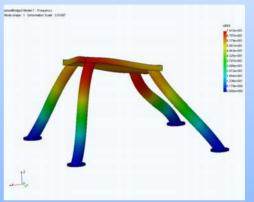
Modes: 1 84.03 Hz

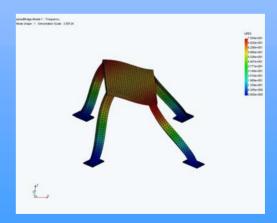
2 84.03 Hz

3 127.28 Hz

- 1/4" wall: 630 lb, 101 Hz

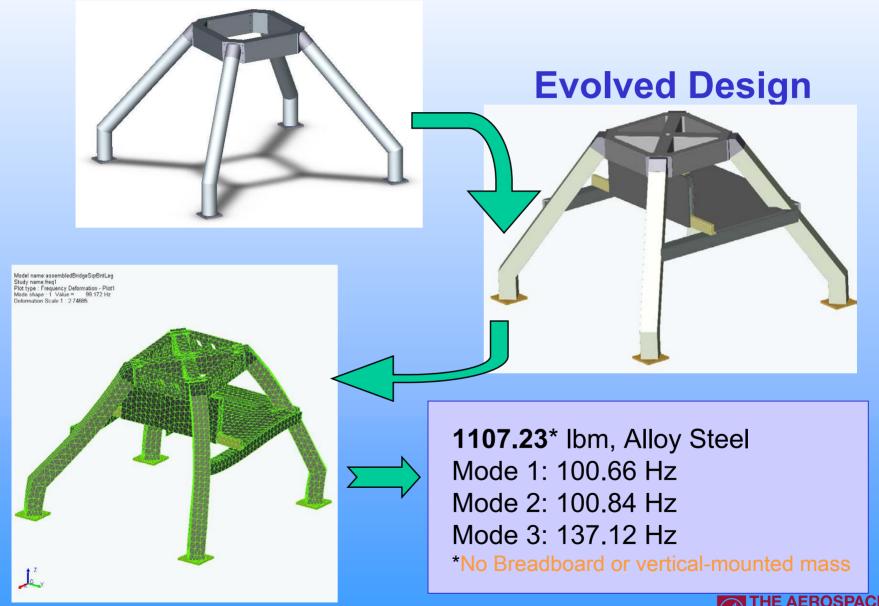




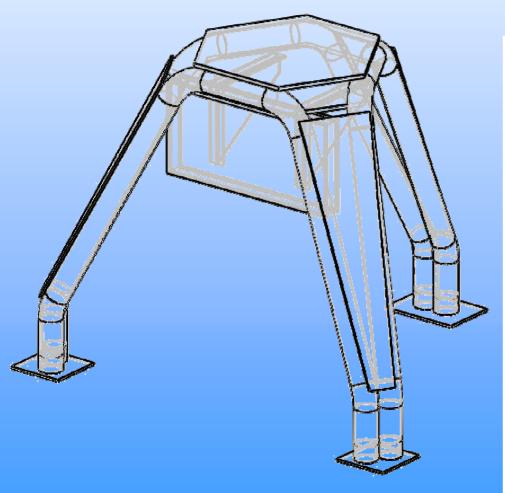




First Design of Support Structure



Alternative Design 1 "Tripod"





Tripod Initial Results

Legs 3" OD, 1/8" thick

506.32 lbm (includes breadboards)

Modes: 1 **57.157 Hz**

2 57.919 Hz

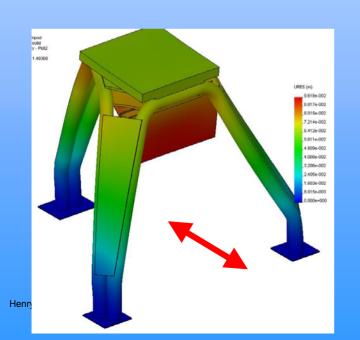
3 117.13 Hz

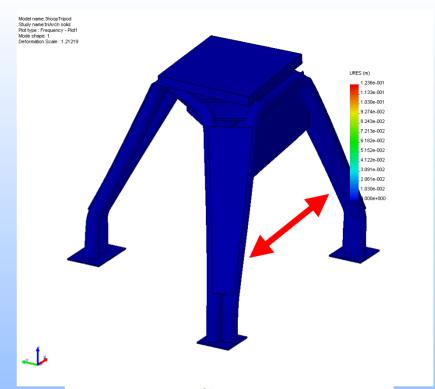
4 180.74 Hz

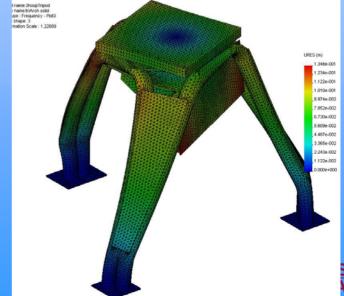
5 204.47 Hz

Solid elements, tetrahedral

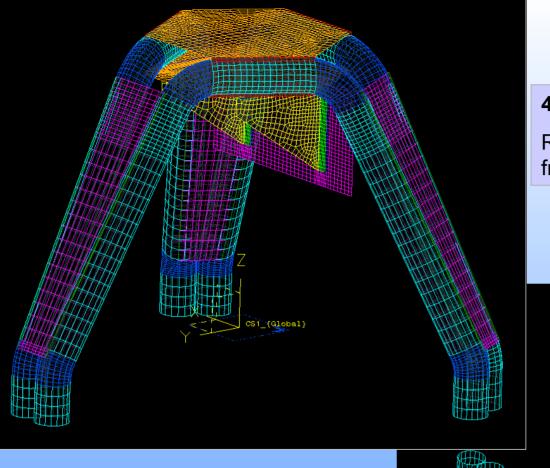
107,963 elements, 199,784 nodes











4" OD legs, 1/16" thick

Requires shell elements, switch from CosmosWorks to NASTRAN

Shell mesh quadrilateral elements
Elastic elements for welds
Ideas preprocessor/mesher

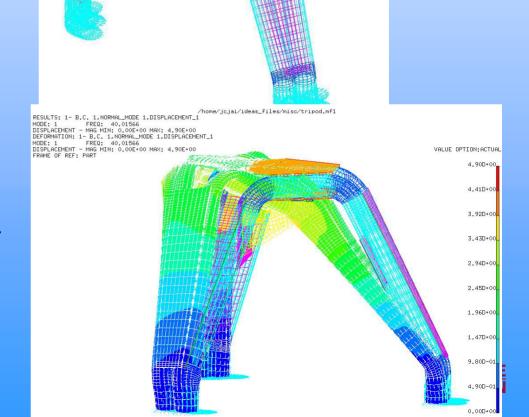
Tripod Analysis and Results

NASTRAN (MSC) solver

Ideas postprocessor/viewer

- 200 lbm point mass at CG of breadboard
- Rigid elements constraints to mounting plate
- •40 lbm breadboard + 15 lbm z-stage added
- Smeared properties for vertical breadboard
- Immovable restraints on bottom of leg, no feet

471.97 Ibm (including breadboards & z stage) First mode at **40** Hz



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Tripod Design Iteration

Plate gussets were added to stiffen bent joints

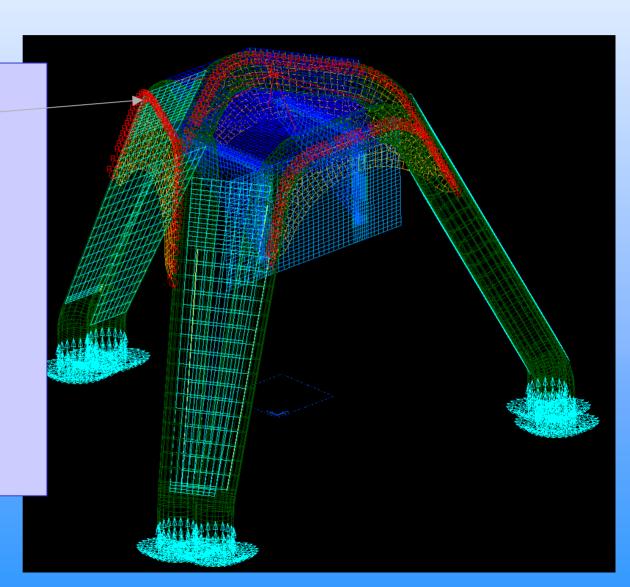
Front plate less than 0.5" blocking of breadboard



Analysis of New Tripod

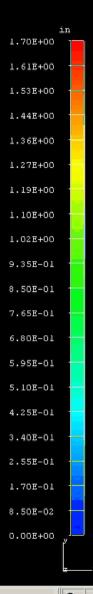
Meshed gusset plates separately Connected by rigid elements

Analysis performed varying
Leg thickness
Gusset thickness
Geometry
combinations



First Mode: Swaying 78 Hz

I-DEAS Visualizer Frame 1 of 8 Display 1 Modal SUB ID=1,MODE=1,F=78.399HZ->MODE SHAPE = LASER TRIPOD DISPLACEMENT Magnitude Unaveraged Top shell Min: 0.00E+00 in Max: 1.70E+00 in SUB ID=1,MODE=1,F=78.399HZ->MODE SHAPE TITLE = LASER TRIPOD DISPLACEMENT XYZ Magnitude Min: 0.00E+00 in Max: 1.70E+00 in Part Coordinate System Frequency: 7.84E+01 Hz





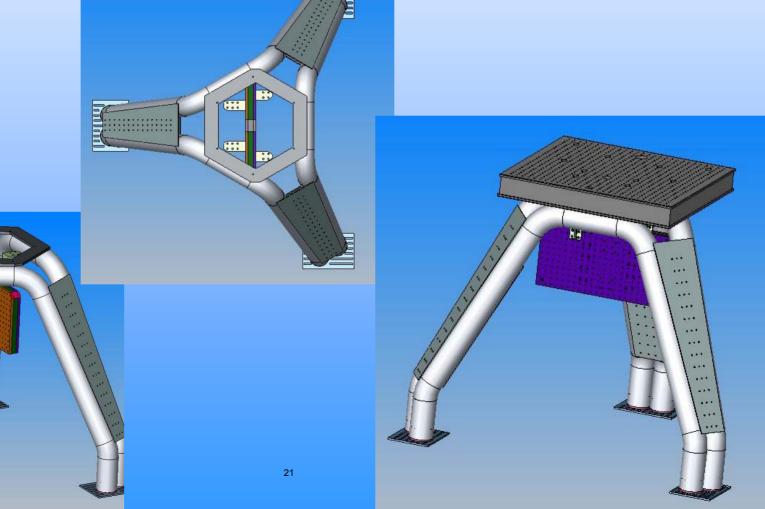
Summary of Analysis Results

	Baseline (1/16" Legs)	1/8" Legs	1/16" Legs + 3/16" Gusset	1/16" Legs + 1/4" Gusset	1/8" Legs + 3/16" Gusset
Mass (lbm)	471.97	534.43	496.52	504.70	558.97
Mode #					
1	39.77	60.39	57.76	58.71	78.40
2	41.00	62.31	63.93	64.70	84.98
3	87.81	109.23	92.09	92.66	112.03
4	102.91	143.72	124.49	126.44	156.18
5	121.12	157.75	132.67	139.12	177.69
6	141.76	217.76	137.94	145.99	179.64
7	166.65	246.62	156.83	158.19	200.99
8	228.80	333.08	160.46	160.68	233.63
9	230.26	339.03	184.82	188.93	256.93
10	231.06	340.48	203.29	222.64	265.52

Problem: Too costly to manufacture "one more try in analysis to refine design"



- Current Design Being Manufactured: 25% Cost Savings
- Material 304SS 4 Inch Diameter Tubing 1/10" Thick
- Weight: 359 lbs (with 100 lbs budget for optical table)
- First resonant mode: 90Hz



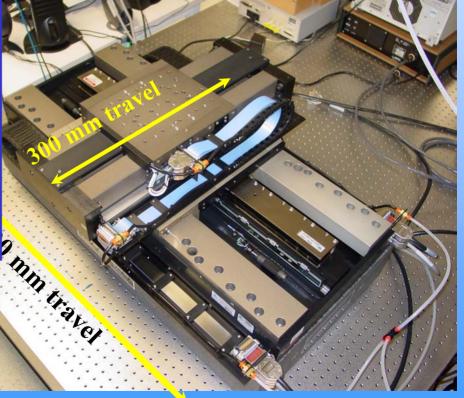
Hardware Delivered Integration Underway



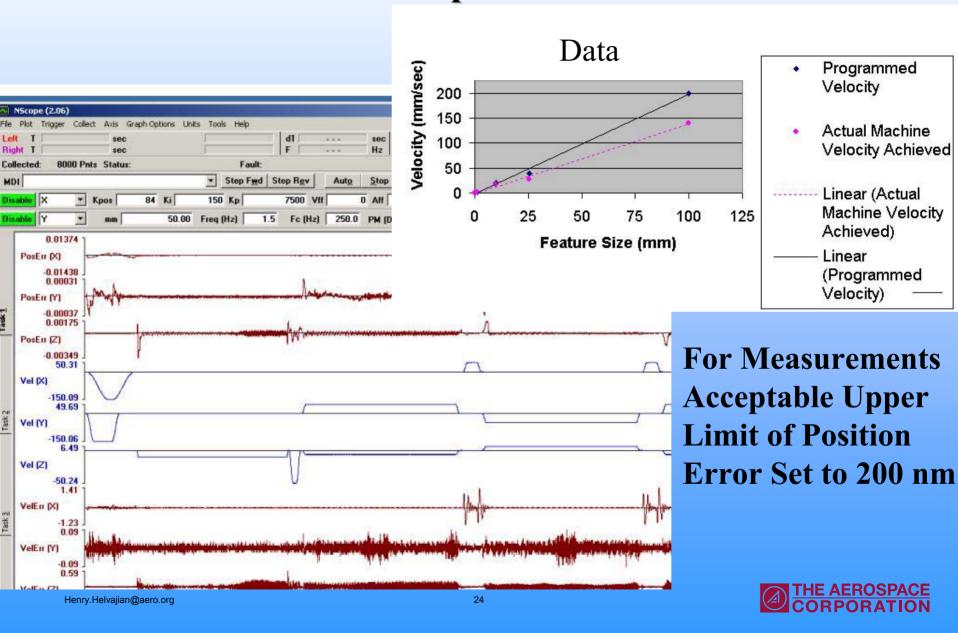


XYZ Motion System





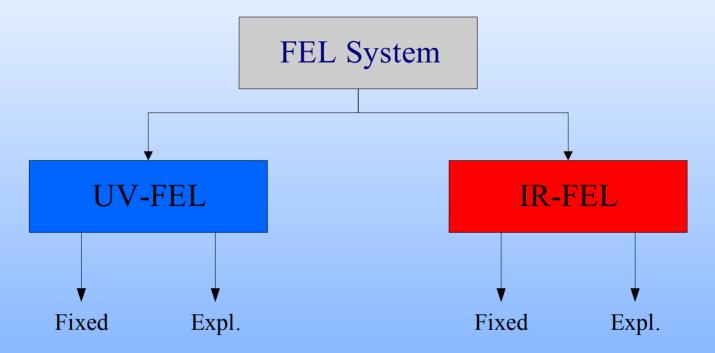
Tradeoff Between Speed and Position-Error



Optical Sub System

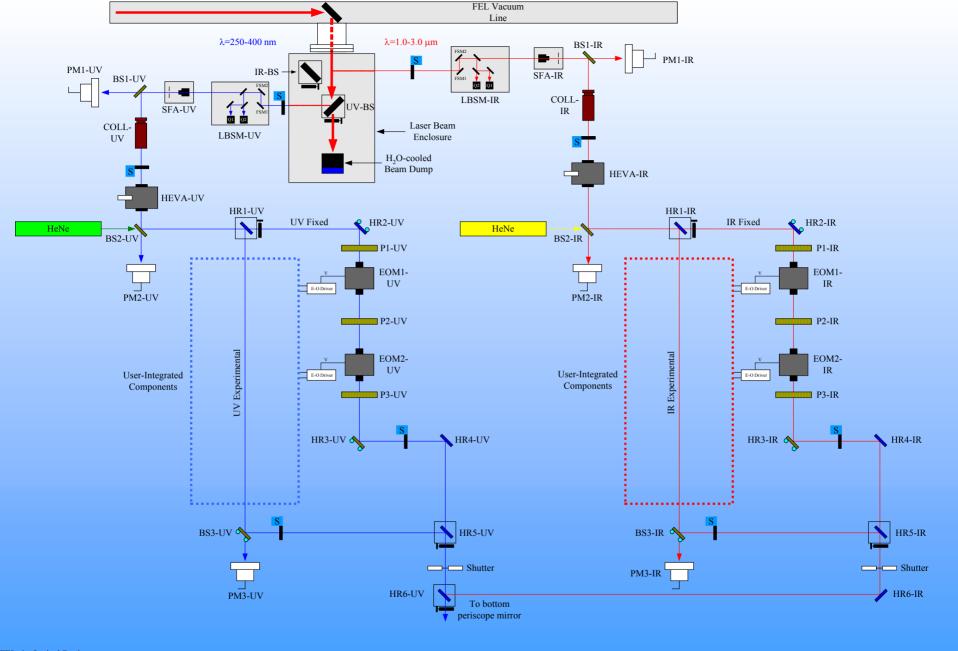


Design Optical Configuration



- 2 Fixed Optical Lines
- 2 Experimental Optical Lines User-integrated components
 - optics
 - diagnostics
 - instrumentation

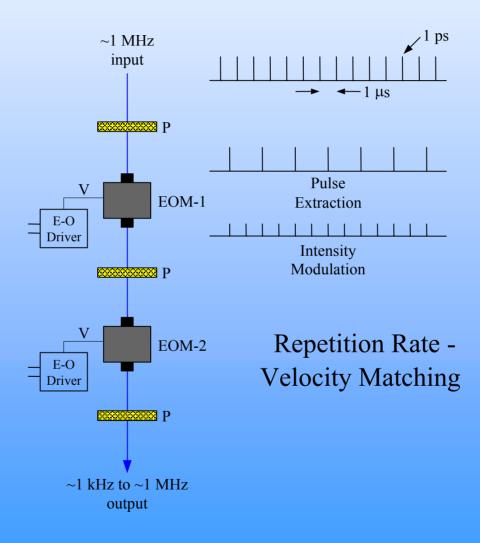




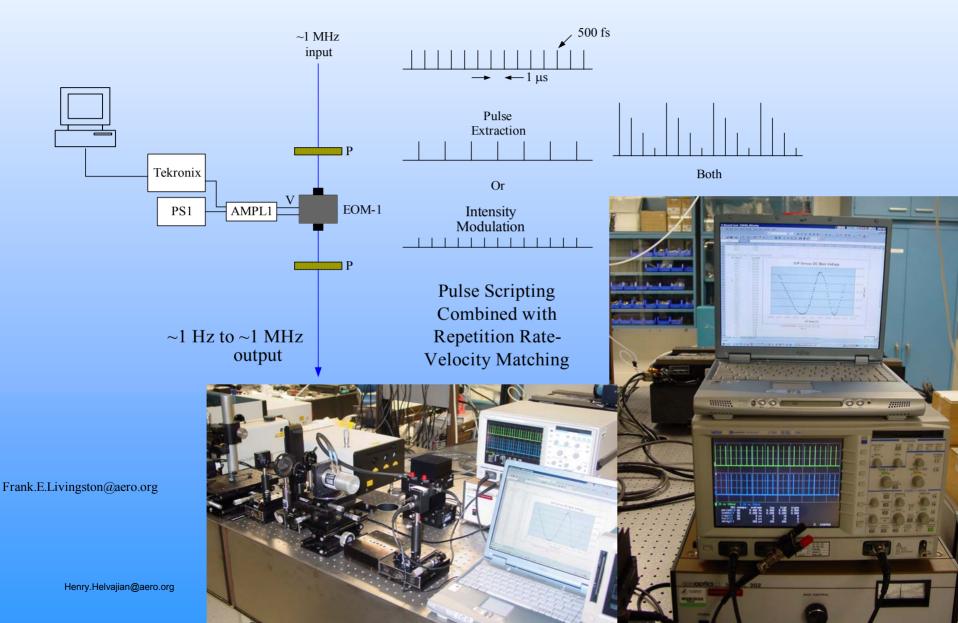


Pulse Picking Velocity Compensation Dynamic Control of Laser Power

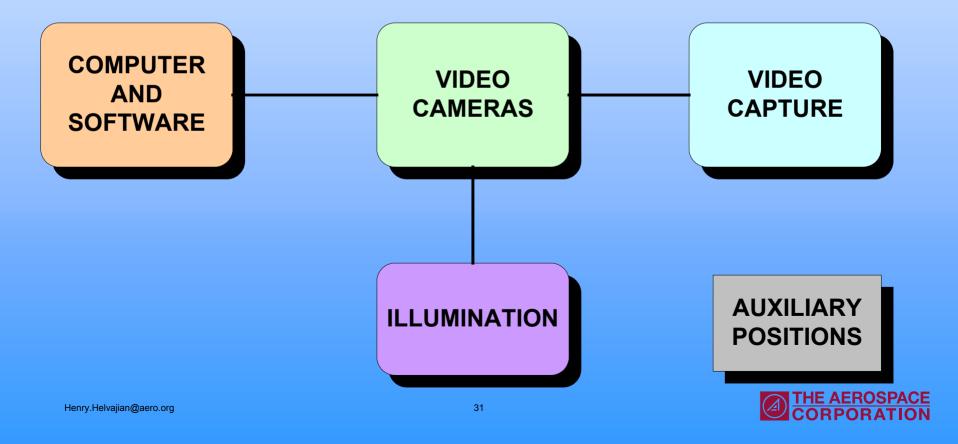
Power Selection and Modulation: EOM Serial Configuration



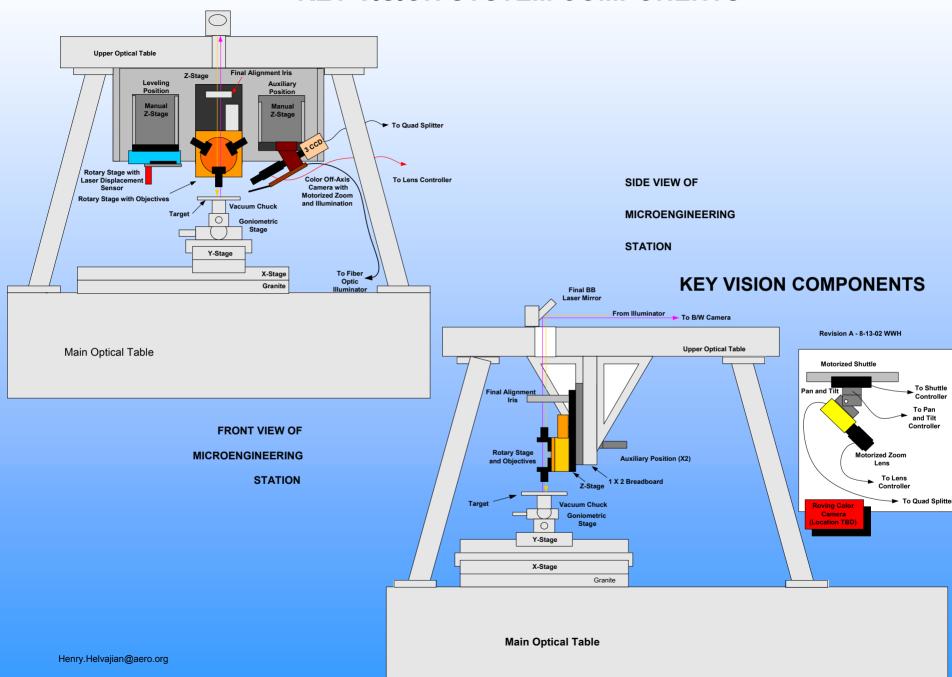
Power Selection and Modulation: EOM Serial Configuration



Key Elements of Vision Subsystem

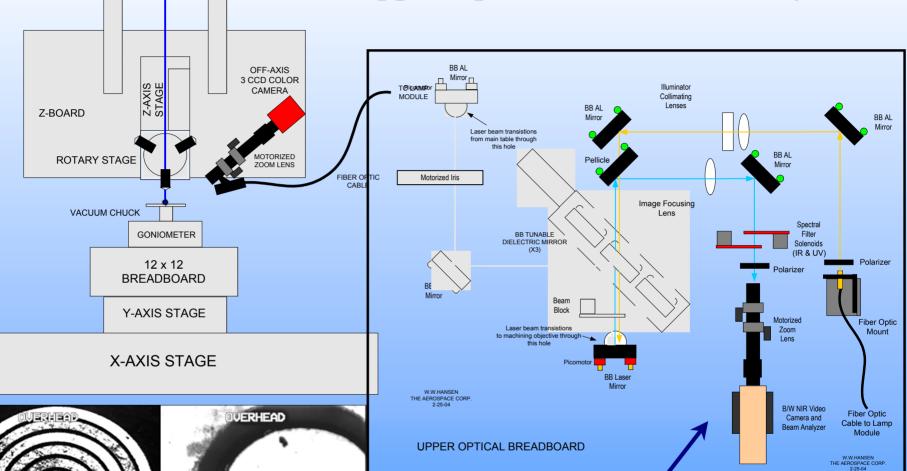


KEY VISION SYSTEM COMPONENTS



UPPER OPTICAL BREADBOARD

Upper Optical Table & Vision System



FOV 1.3mm

FOV 0.2mm

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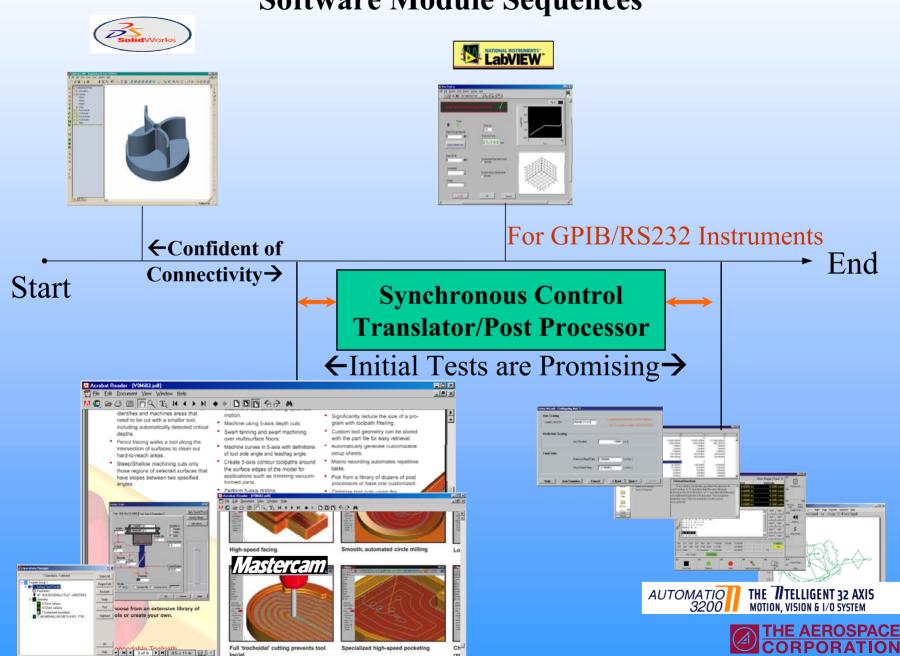
In situ laser beam analyzer for on target laser spot size and intensity distribution measurements



CADCAM

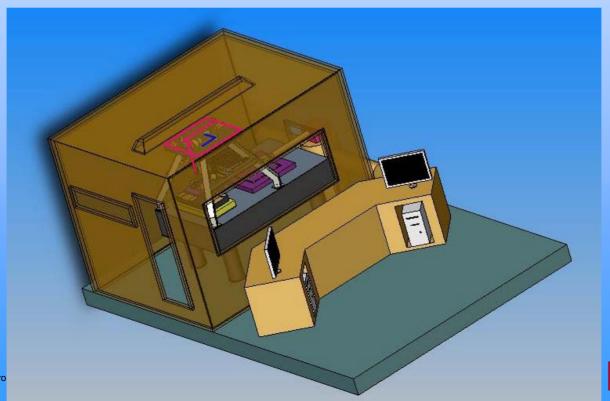


Software Module Sequences



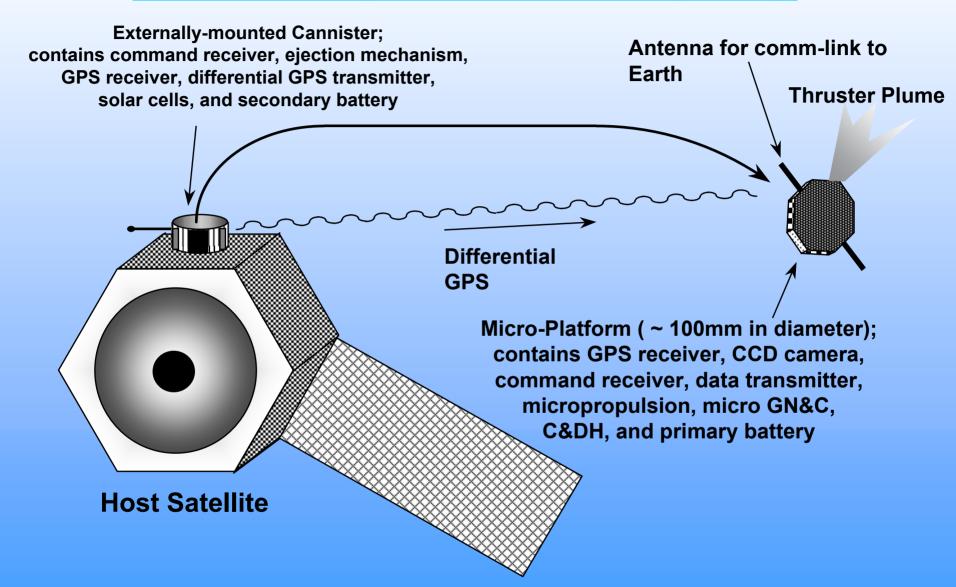
Conclusions

- Have assembled several test 'stands" and have investigated design properties of critical subsystems,
- Engineering Model testing underway,
- Hope to Deliver JLAB Unit Spring/Summer 2005





The Co-Orbiting Satellite Assistant (COSA)



COSA Observation Trajectories

Co-orbital with Inclination:

 $F\delta t = m \Delta v$ $\Delta v = 1mN(1s)/0.1Kg$ $\Delta v = 0.01m/sec$

Phasing orbit (Δv):

- 1st impulse: 0.003m/s

- 2nd impulse: 0.003m/s

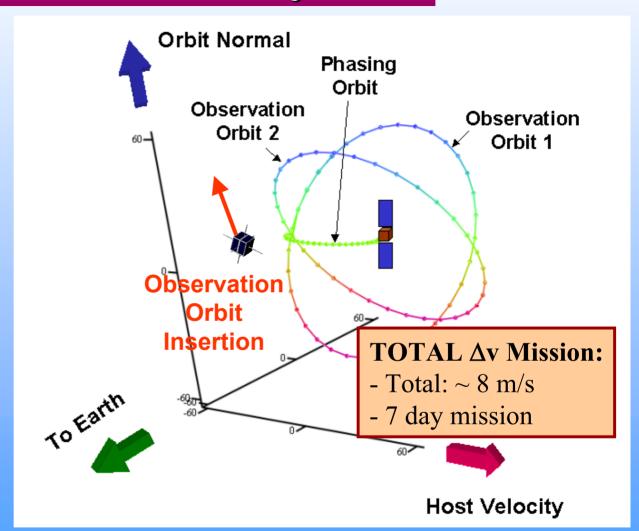
- 700 km orbit

-99 minute/orbit

-mN thrust levels

Observation orbits (Δv):

- Total: $\sim 0.18 \text{ m/s}$



Atmospheric Drag(Δv):

- Total: \sim 7 m/s

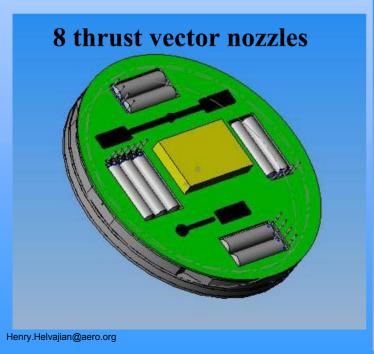
De-orbit (Δv):

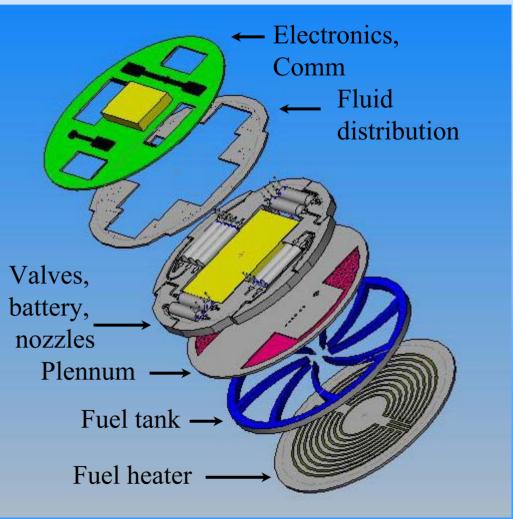
- Total: $\sim 0.17 \text{ m/s}$



CO-Orbiting Satellite Assistant (COSA)

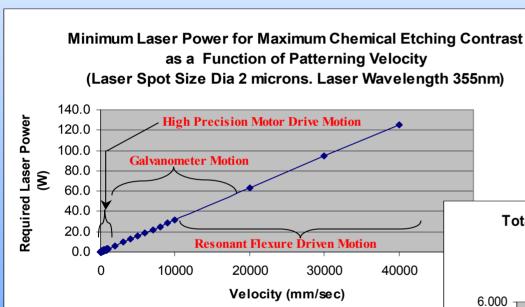
- Status
 - -Vehicle design is complete
 - 9cm dia x 1cm thick
 - Total weight 160 gm
 - Mission 1 week
 - Disposable satellite
 - -Fabrication to begin in April.





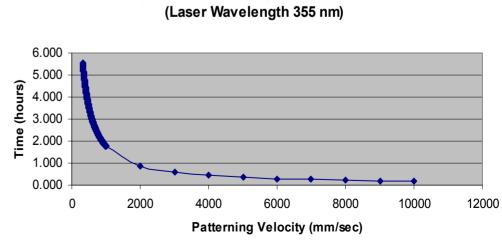
Exposure Time & Required Power: An Illustrative Case Study

For laser wavelength of 355nm, a spot size of $2\mu m$ and patterning speed of 1mm/sec, A minimum laser irradiance (I) of 1mw/ μm^2 is needed to obtain the maximum etch rate (@ 266nm, I ~ 0.2 mw/ μm^2)



For 266nm Laser Wavelength the Required Laser Power is a factor of 5 less, but the penetration depth is ~350 μm

Processing Examples
Based on Data from
Existing PSGC Material

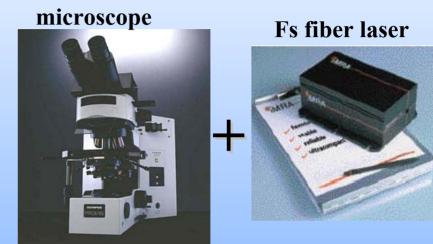


Total Exposure Time to Completely "Paint" a 100mm Square

Sample with 2 Micron Spot Size Resolution

Manufacturing Type Scenarios Using Digital Scripted Processing of PSGC Materials Using a Direct-Write Scheme

- Small Intranet Linked Workstations
 - Integration of a bench top microscope, with a nominal XYZ motion system coupled with a miniature femtosecond laser for small-scale 3D exposure patterning.
- High Throughput and Very Large Area Manufacturing Facility.
 - Up to KW of UV pulsed laser light,
 - With 250W incident UV laser light,
 - A processing speed of 10 meters/sec,
 - 11 μm diameter spot size,
 - A 100 mm square surface is <u>completely</u> patterned or "painted" in <u>under 2 minutes.</u>





DOE – Jefferson Laboratory Free Electron Laser Processing Facility

